

Inventor Name Search Result

Your Search was:

Last Name = SHIMODA

First Name = KAZUHITO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 4
10276927	Not Issued	030	11/20/2002	REFLECTIVE DISPLAY DEVICE, LIGHT GUIDE PLATE AND METHOD OF MANUFACTURING LIGHT GUIDE PLATE	SHIMODA, KAZUHITO
09947703	Not Issued	030	09/06/2001	DISPLAY DEVICE	SHIMODA, KAZUHITO
09688633	Not Issued	161	10/16/2000	OPTICAL COMPONENT, MANUFACTURING METHOD THEREOF AND OPTICAL COMPONENT MANUFACTURING DEVICE	SHIMODA, KAZUHITO
09688541	Not Issued	071	10/16/2000	APPARATUS AND METHOD FOR PRODUCING OPTICAL COMPONENT	SHIMODA, KAZUHITO

Inventor Search Completed: No Records to Display.

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Inventor Name Search Result

Your Search was:

Last Name = OHSAKO

First Name = JUNICHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 7
10614688	Not Issued	019	07/07/2003	PROJECTION SCREEN AND METHOD FOR MANUFACTURING THE SAME	OHSAKO, JUNICHI
10276927	Not Issued	030	11/20/2002	REFLECTIVE DISPLAY DEVICE, LIGHT GUIDE PLATE AND METHOD OF MANUFACTURING LIGHT GUIDE PLATE	OHSAKO, JUNICHI
10005960	Not Issued	030	12/03/2001	DISPLAY DEVICE, PRODUCING METHOD OF ELECTRONIC APPARATUS AND DISPLAY DEVICE	OHSAKO, JUNICHI
09947703	Not Issued	030	09/06/2001	DISPLAY DEVICE	OHSAKO, JUNICHI
09688541	Not Issued	071	10/16/2000	APPARATUS AND METHOD FOR PRODUCING OPTICAL COMPONENT	OHSAKO, JUNICHI
09662879	Not Issued	095	09/15/2000	INPUT DEVICE AND ELECTRONIC APPARATUS HAVING THE SAME	OHSAKO, JUNICHI
08354848	5527377	150	12/09/1994	MANUFACTURING METHOD OF METAL OR ALLOY	OHSAKO , JUNICHI

Inventor Search Completed: No Records to Display.

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<input type="text" value="OHSAKO"/>	<input type="text" value="JUNICHI"/>
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L Number	Hits	Search Text	DB	Time stamp
1	0	(Sony.as. or Ohsako.in. or Shimoda.in.) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index)) and (tuning adj layer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:00
2	0	(Sony.as. or Ohsako.in. or Shimoda.in.) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index)) and (thickness with (control\$4 or measur\$5 or monitor\$3 or determin\$5) with ((optical adj characteristic) or transmittance))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 10:00
3	0	(Sony.as. or Ohsako.in. or Shimoda.in.) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index)) and (thickness same (control\$4 or measur\$5 or monitor\$3 or determin\$5) same ((optical adj characteristic) or transmittance))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 10:02
4	0	(Sony.as. or Ohsako.in. or Shimoda.in.) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index)) and ((remov\$3 or etch\$3) near4 (coat\$3 or film or layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 10:02
5	0	(Sony.as. or Ohsako.in. or Shimoda.in.) and (tuning adj layer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 10:02
6	36	(Sony.as. or Ohsako.in. or Shimoda.in.) and (thickness with (control\$4 or measur\$5 or monitor\$3 or determin\$5) with ((optical adj characteristic) or transmittance))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 10:57
7	1189	(427/8,9).CCLS.	USPAT; US-PGPUB	2003/12/03 10:58
8	506	(427/10).CCLS.	USPAT; US-PGPUB	2003/12/03 10:58
9	2631	(427/162,163.1,163.2,164,166).CCLS.	USPAT; US-PGPUB	2003/12/03 10:58
10	423	(427/419.3).CCLS.	USPAT; US-PGPUB	2003/12/03 10:58
11	1021	(359/580,581,586,587,588).CCLS.	USPAT; US-PGPUB	2003/12/03 10:59
12	890	(118/668,672,677,679,684).CCLS.	USPAT; US-PGPUB	2003/12/03 10:59
13	781	(216/24,37).CCLS.	USPAT; US-PGPUB	2003/12/03 10:59
14	6905	((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)	USPAT; US-PGPUB	2003/12/03 11:00
15	42	((427/10).CCLS.) and ((427/162,163.1,163.2,164,166).CCLS.) or ((427/419.3).CCLS.) or ((359/580,581,586,587,588).CCLS.) or ((216/24,37).CCLS.)	USPAT; US-PGPUB	2003/12/03 11:07

16	53	((427/10).CCLS.) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))	USPAT; US-PGPUB	2003/12/03 11:58
17	10	((427/10).CCLS.) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/12/03 11:47
18	0	((Sony.as. or Ohsako.in. or Shimoda.in.) and (thickness with (control\$4 or measur\$5 or monitor\$3 or determin\$5) with ((optical adj characteristic) or transmittance))) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with correct\$3)	USPAT; US-PGPUB	2003/12/03 11:20
19	79	((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with correct\$3)	USPAT; US-PGPUB	2003/12/03 11:24
20	186	((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer))	USPAT; US-PGPUB	2003/12/03 11:32
21	177	((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer))) not (((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with correct\$3))	USPAT; US-PGPUB	2003/12/03 11:25
22	3	((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and (tuning adj (coat\$3 or film or layer))	USPAT; US-PGPUB	2003/12/03 11:31
23	10	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness	USPAT; US-PGPUB	2003/12/03 12:02
24	259	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (coat\$3 or film or layer)) with correct\$3 with thickness	USPAT; US-PGPUB	2003/12/03 11:35

25	247	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (coat\$3 or film or layer)) with correct\$3 with thickness) not (((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer))) or (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness))	USPAT; US-PGPUB	2003/12/03 11:36
26	94	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)	USPAT; US-PGPUB	2003/12/03 12:03
27	86	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness) not (((427/8,9).CCLS.) ((427/10).CCLS.) ((427/162,163.1,163.2,164,166).CCLS.) ((427/419.3).CCLS.) ((359/580,581,586,587,588).CCLS.) ((118/668,672,677,679,684).CCLS.) ((216/24,37).CCLS.)) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer))) or (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with ((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness))	USPAT; US-PGPUB	2003/12/03 11:36
28	204	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with ((proper or desir\$6) near4 thickness)	USPAT; US-PGPUB	2003/12/03 12:04
29	197	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with ((proper or desir\$6) near4 thickness) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness))	USPAT; US-PGPUB	2003/12/03 11:41
30	271408	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))	USPAT; US-PGPUB	2003/12/03 12:06
31	476	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((427/8,9).CCLS.) or ((427/10).CCLS.) or ((118/668,672,677,679,684).CCLS.))	USPAT; US-PGPUB	2003/12/03 11:46

32	12048	((((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))	USPAT; US-PGPUB	2003/12/03 11:47
33	371	((((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 11:48
34	366	(((((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index))) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)) or (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with ((proper or desir\$6) near4 thickness)) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/12/03 11:58
35	28054	((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 11:59
36	861	((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3)) with (coat\$3 or film or layer or multilayer or filter) with (deposit\$3 or thickness)	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:06
37	21	((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3)) with (coat\$3 or film or layer or multilayer or filter) with (deposit\$3 or thickness)) and ((multilayer or (multi adj layer) or (multiple adj layer) or (plural\$3 adj layer) or alternat\$3) same (high near2 refract\$3 near2 index) same (low\$2 near2 refract\$3 near2 index))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:00
38	1	((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3)) and (tuning adj (coat\$3 or film or layer))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:01

39	315	((((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3))) and ((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:02
40	3	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:02
41	27	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:03
42	27	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness)	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:03
43	54	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with ((proper or desir\$6) near4 thickness)	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:05
44	54	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with ((proper or desir\$6) near4 thickness)) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer)) with (correct\$3 near4 thickness)) not (((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) with (((tuning or inner or under or lower) near2 (coat\$3 or film or layer)) or underlayer)) with correct\$3 with thickness)	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:05
45	231328	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:06
46	315	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3)))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:07
47	58	((thinned or thinning or etch\$3 or remov\$4 or trim\$4 or mill or milled or milling) near4 (coat\$3 or film or layer or underlayer))) and (((optical adj characteristic) or transmit\$7 or reflect\$6) near4 (max\$4 or min\$4 or extreme or extrema or increas\$3 or decreas\$3)) with (coat\$3 or film or layer or multilayer or filter) with (deposit\$3 or thickness))	EPO; JPO; DERWENT; IBM_TDB	2003/12/03 12:07